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THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/721,719 : Confirmation No.: 5752
Applicant : Dingjun Wu
Filed : 11/25/2003
For : METHOD FOR CLEANING DEPOSITION CHAMBERS FOR HIGH DIELECTRIC CONSTANT MATERIALS

Art Unit : 3749
Examiner : Kenneth Rinehart

Docket No. : 06469 USA
Customer No. : 23543

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Amendment and Response to Final Office Action

Sir:

Enclosed herewith is an amendment and response to the Office Action mailed 8 April 2005. Please amend the above-identified application as follows:

- ☐ **Amendments to the Specification** begin on page _____ of this paper.
- ☒ **Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.
- ☒ **Amendments to the Drawings** begin on page _____ of this paper and include an attached replacement sheet(s).
- ☐ **Amendments to the Abstract** are on page _____ of this paper. A clean version of the Abstract is on page _____ of this paper.
- ☒ **Remarks/Arguments** begin on page 7 of this paper.